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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

**Takayuki WATANABE, et al.**

Serial No.: **10/024,391**

Group Art Unit: 1765

Filed: **December 21, 2001**

P.T.O. Confirmation No.: 5820

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING OPTICAL WAVE GUIDE**

**PRELIMINARY AMENDMENT**

**Commissioner for Patents  
Washington, D.C. 20231**

April 10, 2002

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

**IN THE SPECIFICATION:**

Amend the specification as follows:

Please delete the paragraph beginning at page 18, line 33 and ending at page 18, line 35.

2001-04-10 14:00:00

**REMARKS**

The specification has been amended in order to place the application in better condition for examination.

Please note that this correction in the specification should cancel the need for an omitted item, since the omitted item was a typographical error in the specification.

Attached hereto is a marked-up version of the changes made to the specification by the current amendment. The attached page is captioned "**VERSION WITH MARKINGS TO SHOW CHANGES MADE**".

In the event that any fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully Submitted,

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Enclosures: Version with markings to show changes made



VERSION WITH MARKINGS TO SHOW CHANGES MADE (10/024,391 )

IN THE SPECIFICATION:

Paragraph beginning at page 18, line 33 and ending at page 18, line 35 has been amended as follows:

FIG. 17F is a view of a manufacturing process of a laser diode of a first embodiment according to the present invention;

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